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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Confirmation No.: 9149

Yoshiaki TATSUMI et al.

Art Unit: 1711

Application No.: 10/774,472

Examiner: Thao T. TRAN

Filed: February 10, 2004

Attorney Dkt. No.: 101160-00026

For: ELECTROSTATIC CHUCKING DEVICE AND MANUFACTURING METHOD
THEREOF

SUPPLEMENTAL RESPONSE TO REJECTION UNDER 37 C.F.R. § 1.121

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 12, 2005

Sir:

This paper is a supplemental reply to the Response submitted July 15, 2005.

Amendments to the claims begin on page 2.

Remarks/arguments begin on page 7.